INTERNATIONAL GEMOLOGICAL INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

October 20, 2026

IGI Report Number	LG849673488
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OVAL BRILLIANT
Measurements	10.14 X 7.12 X 4.46 MM

GRADING RESULTS

Carat Weight	2.07 CARATS
Color Grade	F
Clarity Grade	VVS 2

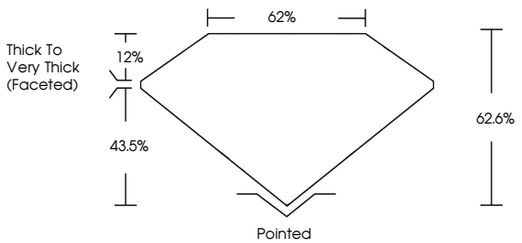
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG849673488

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG849673488
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

© IGI 2020, International Gemological Institute

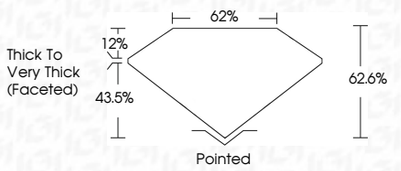
FD - 10 20

THIS DOCUMENT WAS PRODUCED WITH THE FOLLOWING SECURITY MEASURES: SPECIAL DOCUMENT PAPER, INK SCREENS, WATERMARK BACKGROUND DESIGNS, HOLOGRAM AND OTHER SECURITY FEATURES NOT LISTED AND DO EXCEED DOCUMENT SECURITY INDUSTRY GUIDELINES.

www.igi.org

LABORATORY GROWN DIAMOND REPORT

October 20, 2026
IGI Report Number LG849673488
Description LABORATORY GROWN DIAMOND
Shape and Cutting Style OVAL BRILLIANT
Measurements 10.14 X 7.12 X 4.46 MM
GRADING RESULTS
Carat Weight 2.07 CARATS
Color Grade F
Clarity Grade VVS 2



ADDITIONAL GRADING INFORMATION
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) IGI LG849673488
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

IGI

October 20, 2026
IGI Report No LG849673488
OVAL BRILLIANT
10.14 X 7.12 X 4.46 MM
Carat Weight 2.07 CARATS
Color Grade F
Clarity Grade VVS 2
Depth 62.6%
Table 62%
Girdle Thick To Very Thick (Faceted)
Culet Pointed
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) IGI LG849673488
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa